

ABSTRACT

**CONDUCTIVE STRUCTURES, SYSTEMS AND DEVICES INCLUDING
CONDUCTIVE STRUCTURES AND RELATED METHODS**

5 Conductive structures include stair step structures positioned along a length of the
conductive structure and at least one landing comprising at least one via extending through
the conductive structure. The at least one landing is positioned between a first stair step
structure of the stair step structures and a second stair step structure of the stair step
structures. Devices may include such conductive structures. Systems may include a
10 semiconductor device and stair step structures separated by at least one landing having at
least one via formed in the at least one landing. Methods of forming conductive structures
include forming at least one via through a landing positioned between stair step structures.

FIGURE 2